

2019 Editorial Calendar

(Editorial close date: 6/14)	July • August	Industry Events * indicates show distribution	
Advances in inspection		• ICEPT 2019 Shanghai, China (Aug 11-15)	
Inkjet printing for packaging applications		• SEMICON Taiwan * Taipei, Taiwan (Sept 18-20) • European MEMS & Sensors Summit Grenoble, France (Sept 19-21) • European Imaging & Sensors Summit Grenoble, France (Sept 19-21)	
Temporary bonding for high temperature processing of thin glass			
Reliability physics analysis			
Advanced IC and MEMS packaging technologies			
MEMS & Sensors			
Ultra-thin packaged ICs			
Glass carriers for temporary bonding			
Large-area fan-out processing			

Ad Space Close Jun 28 - Ad Materials Close Jul 8

(Editorial close date: (8/2)	September • October	Industry Events * indicates show distribution
Effective, Scalable EMI Protection Embedded RDL High density flip-chip and advanced CSP High-resolution 3D X-ray metrology Advanced substrates and embedded packaging High density advanced packaging (HDAP) design Direct-placement process for LED's Inkjet printing for packaging applications		•SMTA International * Rosemont, IL (October 24-25) • IWLPC-International Wafer-Level Packaging Conference & Exhibition * San Jose, CA (Oct 22-24) • IMPACT Taipei, Taiwan (October 24-26) • TestConX China 2019 Suzhou, China (Oct 23) Shenzhen, China (Oct 25) • International Test Conference (ITC) Phoenix, AZ (Oct 28- Nov 2) • SEMI International Technology Partners Conference (ITPC) Maui, Hawaii (Nov 4-7) • SEMICON Europa / Productronica Munich, Germany (Nov 12-16)
1		Mullion, Germany (NOV 12-16)

International Directory of Defect Inspection Systems

Ad Space Close Sep 6 - Ad Materials Close Sep 13

(Editorial close date: 10/4)	November • December	Industry Events * indicates show distribution	
Collective bonding for heterogeneous integration		• EPTC 2019 * Singapore (Dec 3-6) • SEMICON Japan Tokyo, Japan (Dec 11-13) • SEMI European 3D Summit * Dresden, Germany (TBD) • SEMICON Korea 2020 Coex, Seoul, Korea (Feb 5-7, 2020)	
Cooling solutions for hi-density chips			
Advanced eWLB for mmWave applications			
High temperature survivability & the processes it allows	3		
TSV and RDL technologies, the road ahead			
Multi-die/ substrate heterogeneous packages			
3D ICs			

Ad Space Close Nov 3 - Materials Close Nov 10